



2625  
29/11

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 09/262,778  
Applicant : Michael J. Penberth et al.  
Filed : March 4, 1999  
TC/A.U. : 2625  
Examiner : Sheela C. Chawan  
Title : ELECTRON BEAM BLANKING METHOD AND SYSTEM  
FOR ELECTRON BEAM LITHOGRAPHIC PROCESSING

Docket No. : 103631-991121  
Customer No. : 26379

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**CERTIFICATE OF MAILING**

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GRAY CARY WARE & FREIDENRICH Date: 10/29/04

By: Cathy Pittman

Cathy Pittman

**RESPONSE TO OFFICE ACTION OF JULY 23, 2004**

Sir:

In response to the Office Action of July 23, 2004, please amend the above identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.